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GEMOLOGICAL
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LABORATORY GROWN DIAMOND REPORT

November 18, 2025

IGI Report Number **LG749583495**

Description **LABORATORY GROWN DIAMOND**

Shape and Cutting Style **PRINCESS CUT**

Measurements **6.57 X 6.54 X 4.71 MM**

GRADING RESULTS

Carat Weight **1.79 CARAT**

Color Grade **E**

Clarity Grade **VVS 2**

ADDITIONAL GRADING INFORMATION

Polish **EXCELLENT**

Symmetry **EXCELLENT**

Fluorescence **NONE**

Inscription(s) **IGI LG749583495**

Comments: This Laboratory Grown Diamond was created by Chemical Vapor Deposition (CVD) growth process.

Type IIa

LG749583495
Report verification at igi.org

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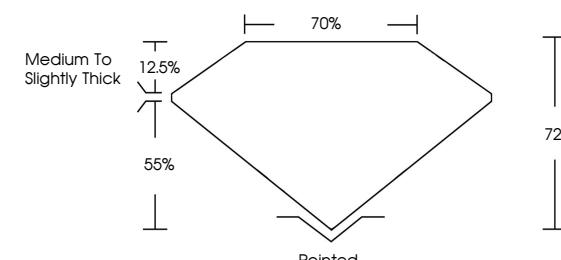
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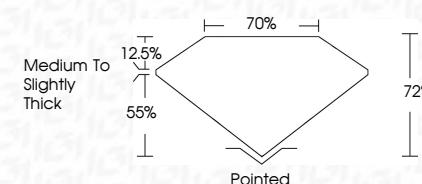
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PROPORTIONS



Sample Image Used



COLOR

D	E	F	G	H	I	J	Faint	Very Light	Light
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CLARITY

FL	IF	VS ¹⁻²	VS ¹⁻²	SI ¹⁻²	I ¹⁻³
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Flawless	Internally Flawless	Very Very Slightly Included	Very Slightly Included	Slightly Included	Included
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PRINCESS CUT

6.57 X 6.54 X 4.71 MM

1.79 CARAT

E

VVS 2

72%

70%

Medium to slightly Thick

Pointed

Excellent

Excellent

NONE

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IGI